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PATENT
Attorney Docket No. 04329.3304-00

THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Ayako NAKANO et al.

Application No.: 10/823,539

Filed: April 14, 2004

For: PATTERN FORMING METHOD AND
SYSTEM, AND METHOD OF
MANUFACTURING A
SEMICONDUCTOR DEVICE

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) Group Art Unit: 1756
)
) Examiner: Stephen D. ROSASCO
)
) Confirmation No.: 4440
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Mail Stop Amendment

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

AMENDMENT

In reply to the Office Action mailed June 1, 2007, the period for response to which extends through September 4, 2007 (September 1 being a Saturday and September 3 being a federal holiday), please amend the above-identified application as follows:

Amendments to the Claims are reflected in the listing of claims in this paper.

Remarks/Arguments follow the amendment sections of this paper.